

Form O-1449
(Rev. 3-83)U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-2095

Serial No. 09/499,619

INFORMATIONAL DISCLOSURE STATEMENT

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Filing Date: February 07, 2000

Group Art Unit: 2815

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
W	4,849,797	07/18/1989	UKAI et al.			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
W	Hatalis et al., "High Performance Thin Film Transistors in Low-Temperature Crystallized LPCVD Amorphous Silicon Films", August 1987, pp. 361-364, IEEE Electron Device Letters, Vol. EDL-8, No. 8

Examiner

Date Considered

6-21-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.